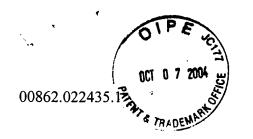
The



## **PATENT APPLICATION**

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
***	: Examiner: H. Nguyen
Kiyoshi ARAKAWA	)
Application No. 10/622 142	: Group Art Unit: 2851
Application No.: 10/622,143	) : Confirmation No.: 1879
Filed: July 18, 2003	. Commination No.: 1879
1 Hod. July 10, 2003	, ·
For: EXPOSURE APPARATUS, MAINTENANCE	· )
METHOD THEREFOR, SEMICONDUCTOR	: October 7, 2004
DEVICE MANUFACTURING METHOD	)
USING THE APPARATUS, AND	:
SEMICONDUCTOR MANUFACTURING	)
FACTORY	:
Mail Stop Amendment	
Commissioner for Patents	
P.O. Box 1450	
Alexandria, VA 22313-1450	
Sir:	
Transmitted herewith is an Amendment in the above-ide	ntified application.
No additional fee is required.	

### The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	2	MINUS	20	= 0	x \$9 \$18	\$0.00
INDEP. CLAIMS	1	MINUS	3	= 0	x \$43 \$86	\$0.00
Fee for Multiple Dependent claims \$145/\$290						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT				\$0.00		

	°Verified Statement claiming small entity status is enclosed, if not filed previously.
	A check in the amount of \$ is enclosed.
	Charge \$ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
X	Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a month extension is enclosed.
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.
X	Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.
	Respectfully submitted,
	Attorney for Applicant Steven E. Warner Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200
SEW/eab

OL W/Cab

DC\_MAIN 180550v1





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	: Examiner: H. Nguyen
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SEMICONDUCTOR MANUFACTURING	)
FACTORY	:

## **Mail Stop Amendment**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

#### <u>AMENDMENT</u>

Sir:

In response to the Official Action dated July 7, 2004, please amend the above-identified application as follows: